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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kenichi SHIRAISHI

Group Art Unit: 2851

Application No.: 10/588,146

Examiner: A. MATHEWS

Filed: November 6, 2006

Docket No.: 128985

For: EXPOSURE APPARATUS, DEVICE MANUFACTURING METHOD,  
MAINTENANCE METHOD, AND EXPOSURE METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the September 3, 2008 Office Action, please consider the following:

**Amendments to the Specification;**

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**